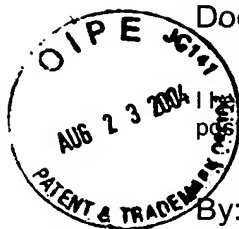


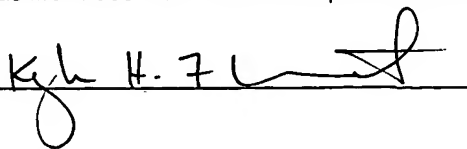
IFW

Docket No.: MUH-12807



I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, Alexandria, VA 22313:

By:



Date: August 17, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/680,379 Confirmation No: 5870
Applicant : Hagen Klauk et al.
Filed : October 6, 2003
Art Unit : 1756
Title : Self-Aligned Contact Doping for Organic Fiel-Effect Transistors
and Method for Fabricating the Transistor
Docket No. : MUH-12807
Customer No.: 24131

LETTER

Mail Stop: Missing Parts
Commissioner for Patents,
Alexandria, VA 22313-1450

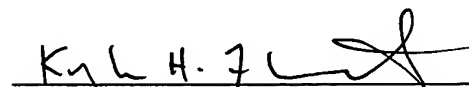
Sir:

The signed declaration was filed in the Patent Office with a mailing certificate and the surcharge on November 28, 2003

Please change the records accordingly.

The U.S. Patent Office charged our credit card account on December 3, 2003.

Respectfully submitted,


KYLE H. FLINDT
REG NO. 42,539

Date: August 17, 2004

Lerner and Greenberg, P.A.
Post Office Box 2480
Hollywood, FL 33022-2480
Tel: (954) 925-1100
Fax: (954) 925-1101

/mjb



United States Patent and Trademark Office

[Home](#) | [Site Index](#) | [Search](#) | [Guides](#) | [Contacts](#) | [eBusiness](#) | [eBiz alerts](#) | [News](#) | [Help](#)

PATENT APPLICATION INFORMATION RETRIEVAL



Search results as of: 8-17-2004::15:30:2 E.T.

Search results for application number: 10/680,379

Application Number:	10/680,379	Customer Number:	24131
Filing or 371(c) Date:	10-06-2003	Status:	Application Undergoing Preexam Processing
Application Type:	Utility	Status Date:	10-15-2003
Examiner Name:	-	Location:	ELECTRONIC
Group Art Unit:	1756	Location Date:	-
Confirmation Number:	5870	Earliest Publication No:	-
Attorney Docket Number:	MUH-12807	Earliest Publication Date:	-
Class/ Sub-Class:	430/-	Patent Number:	-
First Named Inventor:	Hagen Klauk, Erlangen, (DE)	Issue Date of Patent:	-
Title Of Invention:	Self-aligned contact doping for organic field-effect transistors and method for fabricating the transistor		

Search Options

Foreign Priority
Image File Wrapper
Publication Review

File History

Date	Contents Description
03-17-2004	Correspondence Address Change
12-30-2003	Notice Mailed--Application Incomplete--Filing Date Assigned
12-18-2003	Cleared by OIPE CSR
12-06-2003	IFW Scan & PACR Auto Security Review
10-06-2003	Initial Exam Team nn